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## BIB DATA SHEET

CONFIRMATION NO. 1649

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/593,560	09/20/2006 RULE	134	1792	33082M353	
<b>APPLICANTS</b> Masaru Amai, Tokyo-To, JAPAN; Kenji Sekiguchi, Yamanashi-Ken, JAPAN; Takehiko Orii, Yamanashi-Ken, JAPAN; Hiroki Ohno, Yamanashi-Ken, JAPAN; Satoru Tanaka, Saga-Ken, JAPAN; Takuya Mori, Saga-Ken, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP05/06675 04/05/2005 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2004-112179 04/06/2004 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 04/20/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /SHARIDAN CARRILLO/ Acknowledged <u>Examiner's signature</u>	<input type="checkbox"/> Met after Allowance <u>Initials</u>	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 7	<b>TOTAL CLAIMS</b> 30	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> SMITH, GAMBRELL & RUSSELL 1130 CONNECTICUT AVENUE, N.W., SUITE 1130 WASHINGTON, DC 20036 UNITED STATES					
<b>TITLE</b> Substrate cleaning apparatus, substrate cleaning method, and medium for recording program used for the method					
<b>FILING FEE RECEIVED</b> 1960	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		